



**MS AF**  
**Response Under 37 C.F.R. 1.116**  
**Expedited Procedure Examining**  
**Group: 3753**  
**PATENT**  
**3449-0184P**

**IN THE U.S. PATENT AND TRADEMARK OFFICE**

Applicant: Kwang H. AN et al. Conf. No.: 2260  
Appl. No.: 10/002,157 Group: 3753  
Filed: December 5, 2001 Examiner: R. Krishnamurthy  
For: VALVE PLATE STRUCTURE

**REQUEST FOR RECONSIDERATION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

***December 2, 2004***

Sir:

In response to the Examiner's final Office Action dated August 2, 2004, the due date having been extended one (1) month to December 2, 2004, the following remarks are respectfully submitted in connection with the above-identified application.

This Response includes Remarks.

12/03/2004 CNGUYEN 00000012 10002157

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